Atmos. Meas. Tech. Discuss., 8, C4801–C4801, 2016 www.atmos-meas-tech-discuss.net/8/C4801/2016/
© Author(s) 2016. This work is distributed under the Creative Commons Attribute 3.0 License.



Interactive comment on "Twin-cuvette measurement technique for investigation of dry deposition of O₃ and PAN to plant leaves under controlled humidity conditions" by S. Sun et al.

S. Sun et al.

Shang.sun@mpic.de

Received and published: 9 January 2016

The comment was uploaded in the form of a supplement: http://www.atmos-meas-tech-discuss.net/8/C4801/2016/amtd-8-C4801-2016-supplement.pdf

Interactive comment on Atmos. Meas. Tech. Discuss., 8, 12051, 2015.

C4801